



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2829
Examiner: J. Hollington

In Re PATENT APPLICATION Of:

Applicant: Mikio OHTAKI

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Appln. No.: 09/904,663

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AMENDMENT

Filed: July 16, 2001

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For: METHOD FOR MANUFACTURING
AND BATCH TESTING
SEMICONDUCTOR DEVICES

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Atty Ref.: KAN 120D1

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September 4, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Mail Stop – Non-Final Office Action

Sir:

Responsive to the Examiner's Action dated May 7, 2003, a Petition for a One-Month Extension of Time being submitted herewith, please amend the application as shown on the following pages.

FEE ENCLOSED:\$110
Please charge any further
fees to our Deposit Account
No. 18-0002